

**Resolution Enhancement Techniques In
Optical Lithography (SPIE Tutorial Texts
In Optical Engineering Vol. TT47)
[Paperback] [2001] (Author) Alfred Kwok-
Kit Wong**

forcing semiconductor manufacturers to extend the current 193 nm optical lithography systems The combined techniques include Resolution Enhancement

http://en.wikipedia.org/wiki/Computational_lithography

Steven R. J. Brueck and Xiaolan Chen "Spatial frequency analysis of optical lithography resolution enhancement techniques", Proc. SPIE 3679, Optical Microlithography

<http://proceedings.spiedigitallibrary.org/proceeding.aspx?articleid=984458>

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Digital resolution enhancement in surface plasmon resolution of optical microscopy and of the optical system. One of such techniques is matrix

<http://arxiv.org/pdf/physics/0512156.pdf>

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University of Texas at Austin Digital Repository Design and development of material-based resolution enhancement techniques for optical lithography

<http://repositories.lib.utexas.edu/handle/2152/22248>

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http://www.lib.nthu.edu.tw/guide/cdrom/intro/data/SPIE_ebooks%20list.xls

Title: Resolution enhancement techniques for optical lithography and optical imaging theory: Authors: Shibuya, Masato: Affiliation: AA(Optical Designing Headquarters

<http://adsabs.harvard.edu/abs/1997OptRv...4..151S>

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We survey the history of resolution enhancement techniques the exciting modern developments that provide resolution enhancement techniques in optical microscopy.

http://www.kip.uni-heidelberg.de/AG_Cremer/sites/default/files/Bilder/2013/2013epjhCremer_Masters.pdf

Jun 30, 2011 Different resolution enhancement techniques for lithography 01 Jul. So, imaging close to the resolution limit of the optical system,

<https://nanoravi.wordpress.com/2011/07/01/different-resolution-enhancement-techniques-for-lithography/>

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The acceleration of integrated circuit miniaturization is challenging lithographers to push the limit of optical lithography by ever more precise engineering and

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Resolution enhancement technologies are methods is known as Optical are usually grouped under the heading resolution enhancement techniques

http://en.wikipedia.org/wiki/Resolution_enhancement_technologies

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<http://www.dlzware.com/to/spie>

Lars W. Liebmann "Resolution enhancement techniques in optical lithography: It's not just a mask problem", Proc. SPIE 4409, Photomask and Next-Generation Lithography

<http://proceedings.spiedigitallibrary.org/proceeding.aspx?articleid=883912>

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